

**Amendments to the Claims:**

The following listing of claims will replace all prior versions, and listings, of claims in the application:

1. (Original) An actuator comprising:  
a silicon structure, integrally formed from single-crystal silicon, having a pair of arms and a connecting part for connecting the arms to each other; and  
respective piezoelectric devices attached to the arms.
2. (Original) An actuator according to claim 1, wherein each piezoelectric device has a form extending in one direction;  
each piezoelectric device being attached to an outer side face of the respective arm such that a longitudinal direction of the piezoelectric device extends along a longitudinal direction of the arm.
3. (Currently Amended) An actuator according to claim 1, wherein the piezoelectric ~~device~~ devices ~~is a~~ are laminated multilayer piezoelectric ~~device~~ devices.
4. (Original) An actuator according to claim 1, wherein the silicon structure is doped with an impurity so as to yield a lower resistance.
5. (Original) A method of making an actuator, the method comprising the steps of:  
etching one surface of a single-crystal silicon substrate so as to form a plurality of plate-like projections arranged in parallel on the single-crystal silicon substrate;  
cutting the single-crystal silicon substrate into a plurality of blocks each having a pair of plate-like projections;  
attaching an elongated piezoelectric device body to an outer side face of each of a pair of plate-like projections in each block; and  
cutting the block having the elongated piezoelectric devices attached thereto into a plurality of actuators each comprising a silicon structure integrally formed with a pair of arms and a connecting part for connecting the arms to each other, and respective piezoelectric devices attached to the arms.